



ITW

00862.022227.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Hiroshi KUROSAWA) : Examiner: R. E. Fuller
Application No.: 10/676,156) : Group Art Unit: 2851
Filed: October 2, 2003) : Confirmation No.: 6709
For: EXPOSURE APPARATUS, MAINTENANCE) January 24, 2005
METHOD THEREFOR, SEMICONDUCTOR : (Monday)
DEVICE MANUFACTURING METHOD, AND)
SEMICONDUCTOR MANUFACTURING :
FACTORY)

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

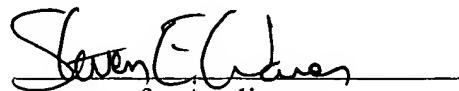
☒ No additional fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	6	MINUS	20	= 0	x \$25 \$50	\$ 0.00
INDEP. CLAIMS	1	MINUS	3	0	x \$100 \$200	\$0.00
Fee for Multiple Dependent claims \$180/\$360						--
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						\$ 0.00

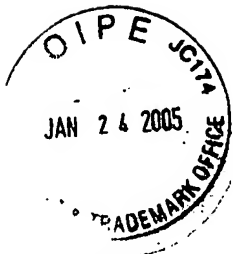
- ☐ Verified Statement claiming small entity status is enclosed, if not filed previously.
- ☐ A check in the amount of \$_____ is enclosed.
- ☐ Charge \$_____ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.
- ☒ Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.
- ☐ A check in the amount of \$_____ to cover the Extension fee for response within one (1) additional month is enclosed.
- ☐ A check in the amount of \$_____ to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address listed below.

Respectfully submitted,


Attorney for Applicant
Steven E. Warner
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
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SEW/eab

DC_MAIN 145044v1



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Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Action dated October 22, 2004, please amend the above-identified application as follows: